

ABSTRACT

The invention relates to a force sensor, comprising: an active layer, wherein an electrical variable of the force sensor depends on a force acting on the active layer in such a way that a change in the electrical variable is caused by a change in the force acting on the active layer; wherein the force sensor comprises an attachment which is arranged relative to the active layer in such a way that a force acting on the force sensor from the outside is conducted onto the active layer by means of the attachment. The invention further relates to a sensor group, an assembly, a set for positioning sensors on opposite regions of a head, a sensor holder for receiving at least one sensor, and uses and methods using the force sensor.